

Application Serial No. 10/738,398
Reply to Office Action of April 27, 2005

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PATENT
Docket: CU-3402

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Yi Sun CHUNG

Serial No: 10/738,398

Filed: December 17, 2003

For: METHOD FOR FORMING METAL-INSULATOR-METAL CAPACITOR OF
SEMICONDUCTOR DEVICE

] GRP ART UNIT: 2891
]
] Ex.: Wilson, Christian D.
]
]

Certification under 37 C.F.R. §1.8(a)

The USPTO Central Fax No. (571) 273-8300

Date of Fax Transmittal: July 25, 2005

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.


W. William Park, Reg. No. 55,523

AMENDMENT UNDER 37 CFR 1.111

Mail Stop Amendment

The Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Sir:

In response to the Office Action dated April 27, 2005, setting a 3-month shortened statutory period for a reply ending on July 27, 2005, Applicant submits the following responsive amendment in the above-identified application. This amendment is considered to place the application in better condition for allowance.

No fee is believed to be required with this amendment, but, if this is not the case, please charge the requisite fee (or credit any overpayment) to Deposit Account No. 12-0400.

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Amendments to the Claims are reflected in the listing of claims, which begins
on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.